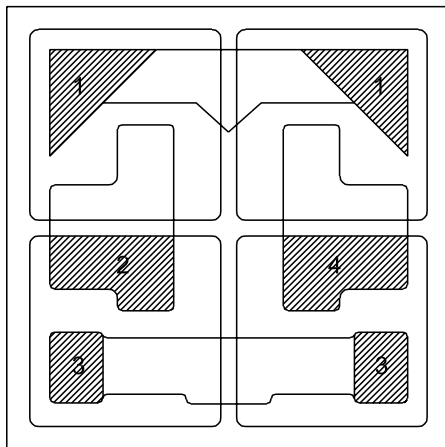


PROCESS DETAILS

Die Size	25 x 25 MILS
Die Thickness	6.0 MILS
Bonding Pad Area 1 (+DC)	3.0 x 3.0 MILS
Bonding Pad Area 2 (AC)	3.0 x 7.0 MILS
Bonding Pad Area 3 (-DC)	3.0 x 4.0 MILS
Bonding Pad Area 4 (AC)	3.0 x 7.0 MILS
Top Side Metalization	Al - 12,000Å
Back Side Metalization	Au - 5,000Å

GEOMETRY



GROSS DIE PER 3 INCH WAFER

10,000

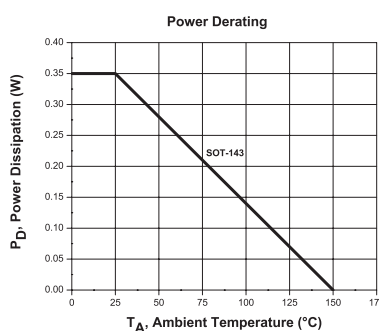
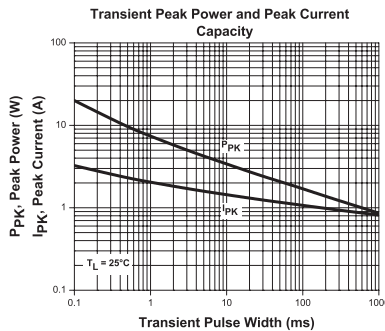
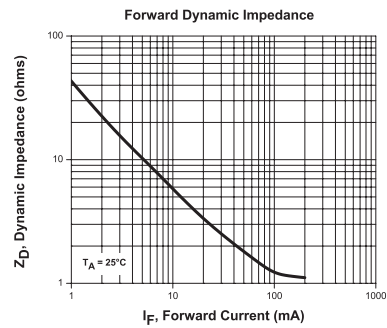
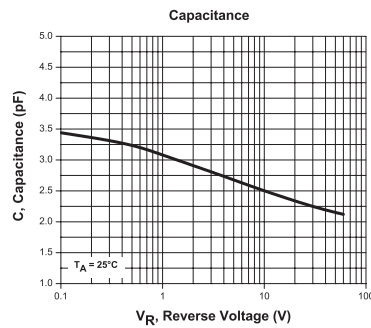
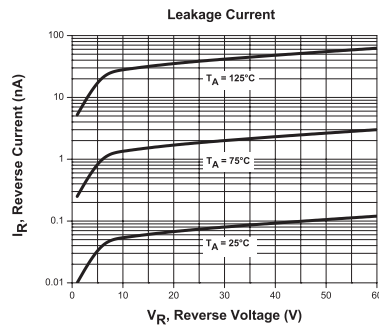
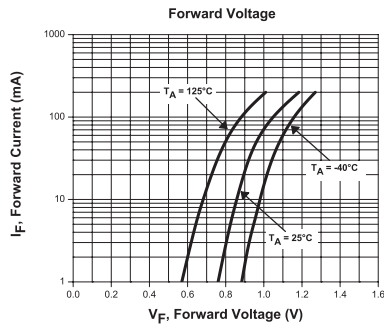
PRINCIPAL DEVICE TYPES

CMFBR-6F

R1

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